Serial No. Filing Date Examiner Group Art U 09/515,285 February 29, 2000 Tuan M. Nguyen 2828 Ivention: Semiconductor Laser and a Manufacturing Method for the Same hereby certify that this	CERTIFICATE OF TRANSMISSION BY FACSIMILE (37 CFR 1.8) Applicant(s): Toshiya Fukuhisa			Docket No. 52478.9100
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